IN THE CLAIMS:

Please cancel claims 13-20.

Please amend the following claims:

1. (Amended) A laminate support used in the process of wire bonding a circuit device comprising: 1 2 a substrate having a first surface; and 3 a wire having a diameter positioned on said first surface of said substrate, said substrate including a closed woven mesh having strands whose separation distance is equal to or 4 5 less than said diameter of said wire on said first surface of said substrate. 4. (Amended) The laminate support used in the process of wire bonding a circuit device in 1 ź accordance with claim 1, wherein said woven mesh comprises fiberglass. 5. (Amended) The laminate support used in the process of wire bonding a circuit device in 1 2 accordance with claim 1, wherein said woven mesh is between approximately 2.5 3 and 4.0 mils thick. 7. (Amended) A laminate support used in the process of wire bonding a circuit device comprising: 1 2 a substrate having a first surface; and 3 a wire having a thickness positioned on said first surface of said substrate, said substrate 4 including a closed woven mesh having warp and weave strands, whose separation 5 distance is equal to or less than the thickness of said wire on said first surface of said